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APPLICATION NO. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/035,257	01/04/2002		Byung-Hee Kim	262/014	2929
. 75	590	07/15/2003			
LEE & STER	BA, P. C.		EXAMINER		
Suite 2000 1101 Wilson Bo			GUERRERO, MARIA F		
Arlington, VA 22209			ART UNIT	PAPER NUMBER	
			2822		
				DATE MAILED: 07/15/2003	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Appli	cant(s)				
		10/035,257	KIME	ET AL.				
•	Office Action Summary	Examiner	Art Ui	nit				
		Maria Guerrero	2822					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Peri df r Reply								
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). Status								
1)	Responsive to communication(s) filed on 06 J	anuary 2003						
2a)□		s action is non-fir	al.					
3)□	Since this application is in condition for allowa			tion as to the merits is				
closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. Disposition of Claims								
4)🖂	4)⊠ Claim(s) <u>1-3</u> is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.								
5)	Claim(s) is/are allowed.							
6)⊠	6)⊠ Claim(s) <u>1-3</u> is/are rejected.							
7)	Claim(s) is/are objected to.							
8)□	Claim(s) are subject to restriction and/or	election requirer	nent.					
Applicati	on Papers							
-	The specification is objected to by the Examiner							
10) 🗌	The drawing(s) filed on is/are: a)□ accep	_	-					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
11)	The proposed drawing correction filed on			the Examiner.				
If approved, corrected drawings are required in reply to this Office action.								
12) The oath or declaration is objected to by the Examiner.								
Priority under 35 U.S.C. §§ 119 and 120								
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).								
a) All b) Some * c) None of:								
	1. Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No3. Copies of the certified copies of the priority documents have been received in this National Stage							
application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.								
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).								
 a) ☐ The translation of the foreign language provisional application has been received. 15)☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121. 								
Attachment(s)								
2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449) Paper No(s)	5) 🗌	Interview Summary (PTO-4 Notice of Informal Patent A Other:					

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DETAILED ACTION

This Office Action is in response to the Amendment filed January 6, 2003.
 Claims 1-3 are pending.

Priority

2. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-3 are rejected under 35 U.S.C. 103(a) as being unpatentable over Yoon et al. (U.S. 6,376,355) in view of Hsu et al. (U.S. 6,143,645).

Yoon et al. teaches a method of fabricating a semiconductor device having a recess in an insulating layer on a silicon substrate (Abstract). Yoon et al. teaches depositing a barrier metal on a whole surface of the insulating layer including the substrate surface in the recess region, selectively depositing an anti-nucleation layer on the barrier metal except in the recess region (Fig. 2, 7-9, col. 1, lines 55-67, col. 2, lines 1-5, 12-15, 25-28, 60-63, col. 4, lines 60-65, col. 5, lines 17-23, 45-49, 63-64). Yoon et al. shows depositing a CVD-Al layer on the barrier metal in the recess region, sputtering (physical vapor deposition (PVD)) the Aluminum layer, and reflowing the PVD-Al layer

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(col. 3, lines 53-56, col. 5, lines 49-51, col. 7, lines 45-50, col. 8, lines 25-28, col. 9, lines 63-67, col. 10, lines 1-5). Youn et al. teaches the metal layer having a thickness of 25-100 Angstroms (col. 5, lines 49-50, col. 6, lines 3-10, 25-35).

Yoon et al. does not specifically show depositing the metal or metal alloy for inhibiting aluminum migration on the anti-nucleation layer. However, Yoon et al. recites, as well known in the art, the necessity to avoid aluminum diffusion (col. 1, lines 33-40). In addition, Hsu et al. discloses depositing a thin diffusion barrier (inhibiting aluminum migration) layer (510) on the barrier metal except in the recess region (Fig. 2B, col. 1, lines 45-50, col. 3, lines 24-32, col. 4, lines 35-45, col. 6, lines 45-50).

Therefore, it would have been obvious to a person of ordinary skill in the art at the time of the invention to modify Yoon et al. reference by including the metal or metal alloy for inhibiting aluminum migration as taught Hsu et al. in order to prevent junction spiking and electromigration (Hsu et al., col. 1, lines 59-65,col. 2, lines 47-50).

Response to Arguments

4. Applicant's arguments with respect to claims 1-3 have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Rhee et al. (U.S. 6,133,147) and Park et al. (U.S. 6,054,768) teach using blocking layer during aluminum deposition as well known in the art.

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6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Maria Guerrero whose telephone number is 703-305-

0162.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Amir Zarabian can be reached on 703-308-4905. The fax phone numbers

for the organization where this application or proceeding is assigned are 703-308-7722

for regular communications and 703-308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is 703-308-

0956.

Maria Guerrero
Patent Examiner

Patent Examine

June 28, 2003